

Notice of References Cited	Application/Control No. 10/594,110		Applicant(s)/Patent Under Reexamination YAMADA, TAKAYUKI	
	Examiner Tony Chuo		Art Unit 1795	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0072060	04-2004	Ukai et al.	429/040
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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	R					
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	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Buchkremer et al ("Advances in the anode supported planar SOFC technology", Electrochemical Proceedings Volume 97-18, 1997
	V	Stover et al ("Recent developments in anode supported thin film SOFC at research centre julich", Electrochemical Society Proceedings, Volume 99-19, 1999)
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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